

## FEE TRANSMITTAL

Electronic Version v08

Stylesheet Version v08.0

Title of Invention	Method of Forming Thin Silicon Oxide Films on Silicon Carbide Substrates
Application Number :	
Date :	
First Named Applicant:	Andrew M. Hoff
Attorney Docket Number:	1372.80.PRC

### TOTAL FEE AUTHORIZED \$ 385

Patent fees are subject to annual revisions on or about October 1st of each year.

Filing as small entity				
BASIC FILING FEE				
Fee Description	Fee Code	Amount \$	Fee Paid \$	
Utility Filing Fee	2001	385	385	Subtotal For Basic Filing Fees: \$ 385
EXTRA CLAIM FEES				
Fee Description	Extra Claim	Fee Code	Amount \$	Fee Paid \$
Total Claims : 10	0	2202	9	0
Independent Claims : 3	0	2201	43	0
Subtotal For Extra Claims Fees: \$ 0				

### AUTHORIZED BILLING INFORMATION

**The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:**

Credit account number: 3008  
Expiration Date (YYYYMMDD): 2004-05-31  
Authorized name: Anton J. Hopen  
Billing address: 33760